



DOCKET NO: VSEA 26-00


IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant: Steven R. Walther  
Serial No: 10/006,462  
Confirmation No: 5689  
Filed: December 4, 2001  
For: DOSE UNIFORMITY CONTROL FOR PLASMA DOPING  
SYSTEMS  
Examiner: Michelle Crowell  
Art Unit: 1763

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**CERTIFICATE OF MAILING UNDER 37 C.F.R. §1.8(a)**

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Janine Canillas

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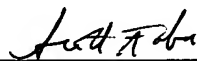
Sir:

Transmitted herewith are the following documents:

- ☒ Amendment
- ☒ Petition for Extension of Time
- ☒ Request for Continued Examination (RCE)
- ☒ Return Receipt Postcard

If any additional fees are determined to be required or if there are any overpayments, Deposit Account 50-0896 may be charged or credited. A duplicate of this sheet is enclosed.

Respectfully submitted,  
*Steven R. Walther, Applicant*

By:   
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